



ETM TELESCOPE PRIMARY PARABOLIC MIRROR ADLIGO

| APPROVALS | DATE | REV | DCN NO. | BY | CHECK | DCC | DATE |
|-----------------------|--------|-----|----------|-----|-------|-----|------|
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| DCC RELEASE | | | | | | | |

1 SCOPE

This is a specification for the ADLIGO ETM TELESCOPE PRIMARY PARABOLIC MIRROR. This concave parabolic mirror is part of an off-axis reflecting beam-reducing telescope.

2 APPLICABLE DOCUMENTS

MIL-C-695C

3 REQUIREMENTS

3.1 PERFORMANCE CHARACTERISTICS

3.1.1 Mirror Fabrication

3.1.1.1 Front Surface, S1

| | |
|--|---|
| Effective focal length | 2000 +/- 20 mm |
| Conic constant | -1.000 +/- 0.002 |
| Tilt tolerance, reference to back surface (S2) | +/- 0.0083 deg |
| Clear aperture diameter | 190 mm |
| Center displacement from optical axis | 562.2 +/- 1 mm |
| Diameter | 230.0 +0.0, -0.1 mm |
| Minimum edge thickness | 43 mm |
| Surface irregularity | <0.25 wave, peak to valley @ 633 nm over clear aperture |
| Surface finish | 60/40 |
| Surface roughness | < 100 Angstrom |
| Chamfer edges | 0.5-1.0 mm, 45 +/- 10 deg |

3.1.1.2 Back Surface, S2

| | |
|-----------------|---------------------------|
| Surface quality | fine ground, > 300 grit |
| Chamfer edges | 0.5-1.0 mm, 45 +/- 10 deg |

3.1.1.3 Mirror Coating

| | |
|--------------------------------|----------------|
| Front surface S1 only | |
| Wavelength | 1064 nm |
| Polarization | S |
| Incidence angle | 8 deg |
| Protected silver, reflectivity | >98% |
| Durability | per MIL-C-695C |

**ETM TELESCOPE PRIMARY PARABOLIC MIRROR ADLIGO****3.2 DESIGN AND CONSTRUCTION****3.2.1 Materials**

Substrate material Zerodur or equivalent

3.2.1.1**3.3 QUALITY ASSURANCE/CONTROL****3.3.1 Identification**

Parts shall be serialized according to paragraph 3.3.1.2.

3.3.1.1 Optical Alignment Marks

Edge orientation mark shall be placed to indicate orientation of mirror with respect to the optical axis, as shown in figure 1: 0.24 +/- 0.05 mm wide x 20 +/- mm long

3.3.1.2 Serial Number

A serial number shall be etched, ground or sandblasted next to the alignment mark with the following format: D1000075-v? S/N nnn; where v? is the drawing revision number and nnn is the sequential serial number, 001 – 999 in the order produced.

3.3.2 Quality Assurance Provisions

A first article shall be produced and inspected.

3.3.3 Purchaser Access

The purchaser will have escorted access to quality control facility during all quality acceptance procedures.

3.3.4 QA Approval

LIGO Quality Assurance reserves the right to inspect and approve vendor/fabricator QA plans and processes.

4 TEST PROCEDURES

The telescope mirror performance shall be verified by the following test procedures

4.1 WAVEFRONT DISTORTION

Interferogram of reflected wavefront across the clear aperture @ 633 nm wavelength

5 DOCUMENTATION

- Compliance Certification for items: 3.1, 3.2, 3.3, 4.
- Interferogram, see 4.1 Wavefront Distortion.

6 ENVIRONMENTAL CHARACTERISTICS

The ETM Telescope will operate in a non-vibrational, ultra high vacuum environment , at 68 +/- 4 deg F.



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7 HANDLING AND SHIPPING PROCEDURES

7.1 Cleaning

Approved cleaning procedures for UHV components are detailed in LIGO-E960022, Vacuum Compatibility, Cleaning Methods and Compatibility Procedures.

All optical surfaces shall be cleaned in accordance with good commercial practice. Nothing shall contact the optical surfaces after cleaning, except for lint-free lens tissue.

7.2 Packaging for Shipment

The cleaned optical components shall be protected with lint-free lens tissue. In addition, all components shall be placed in individual, sealed, clean polyethylene bags before shipping.

The shipping containers must ensure that the bag does not become punctured and that the parts are properly protected during transit.

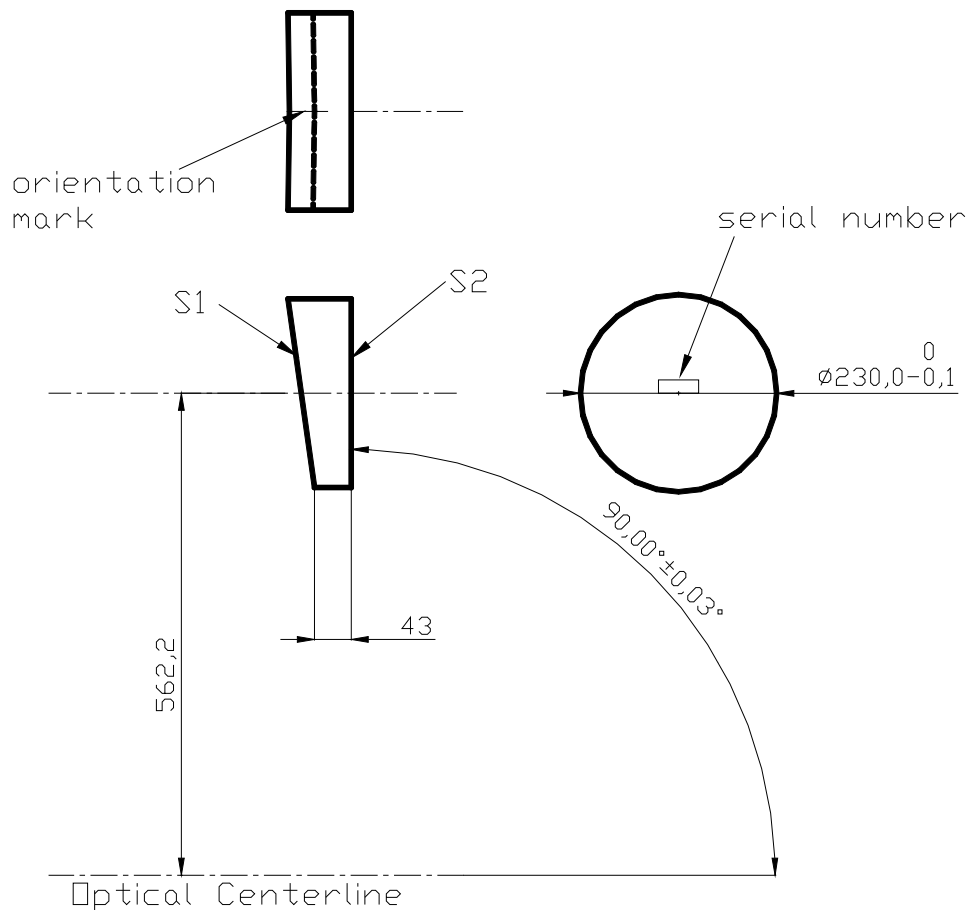


Figure 1: Mirror drawing, parabolic primary mirror